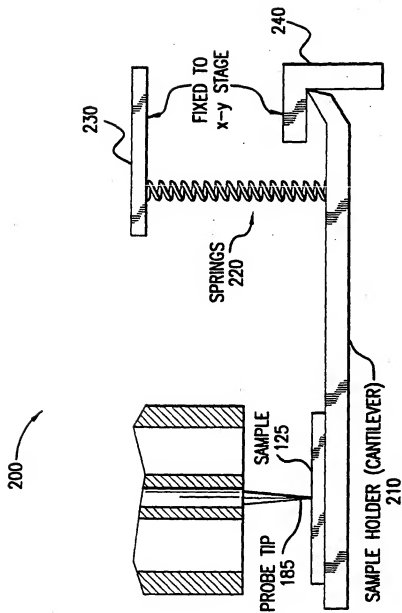




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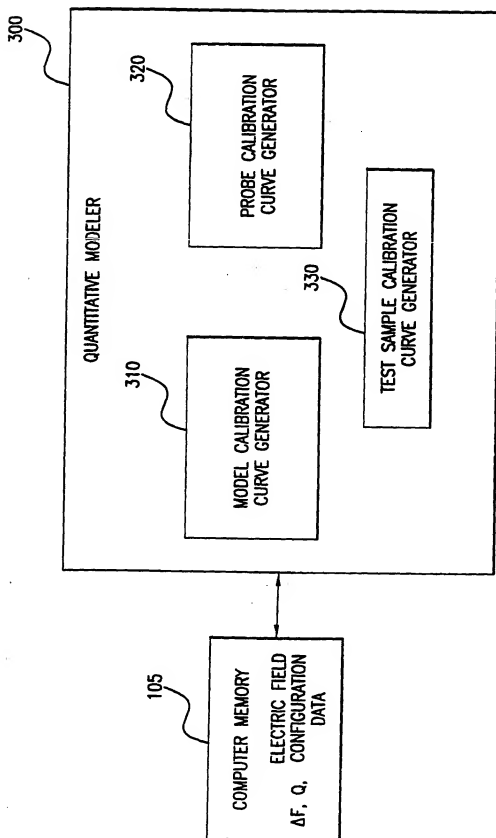


FIG.3

207020" 96669001

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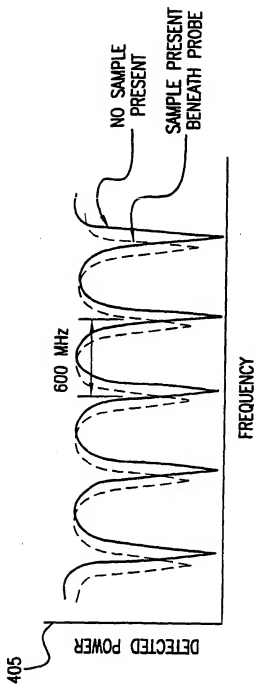


FIG.4

PERTURBATION FORMULA

$$\frac{\Delta f}{f} \approx \frac{(\epsilon_1 - \epsilon_2)}{4W} \int_V \vec{E}_1 \cdot \vec{E}_2 dV$$

$$\Delta f = f(\epsilon_1, \epsilon_2)$$

FIG.5

1066995.030102

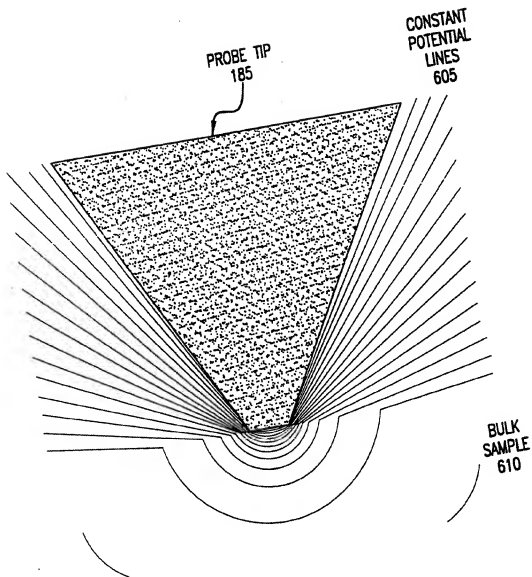


FIG.6

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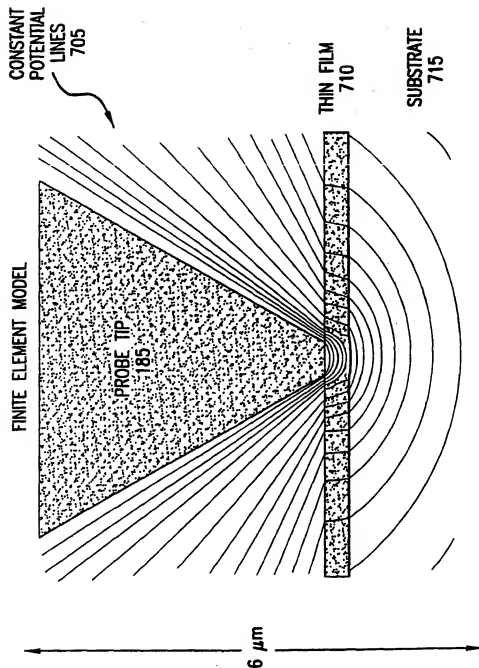


FIG. 7

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$t=0.5$

α		
	1	2
ξ_r	<div>ELECTRIC FIELD CONFIG. FILE</div>	
10		
50		
100		
200		

ELECTRIC FIELD
CONFIGURATION DATA
FILE CONTENTS

ξ_r	t	α
$\phi(r,z)$		

FIG.8

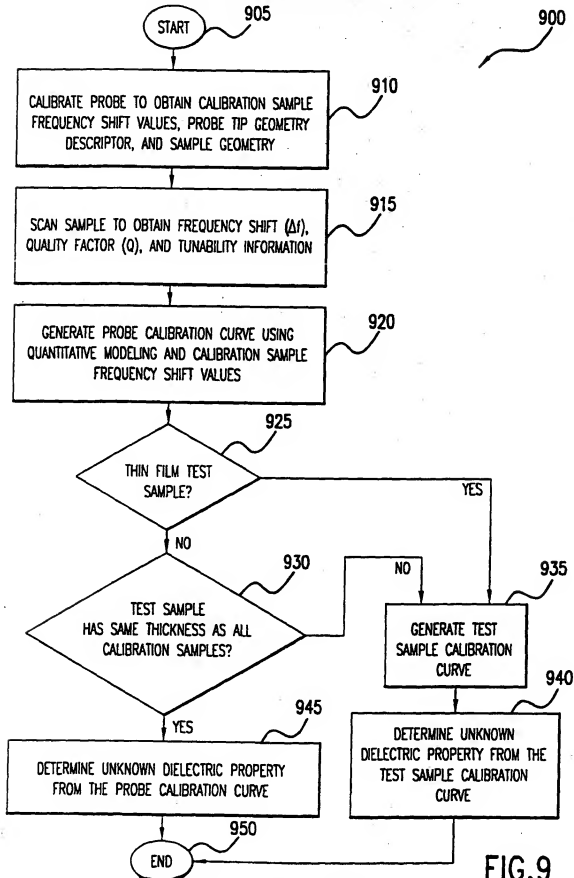
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ROUTINE FOR DETERMINING DIELECTRIC PROPERTIES

FIG.9

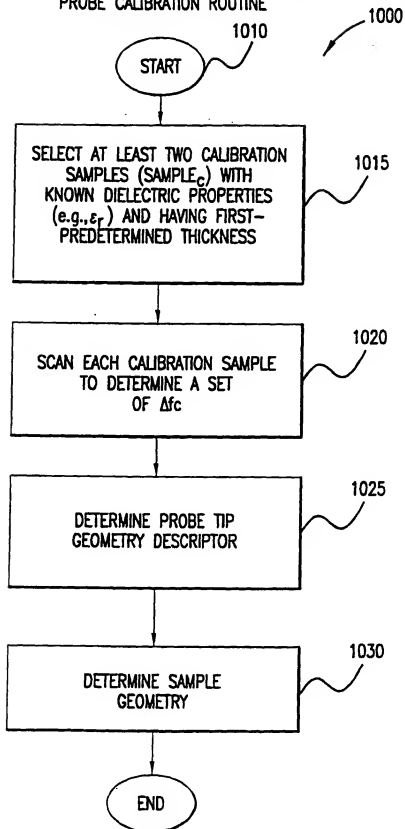
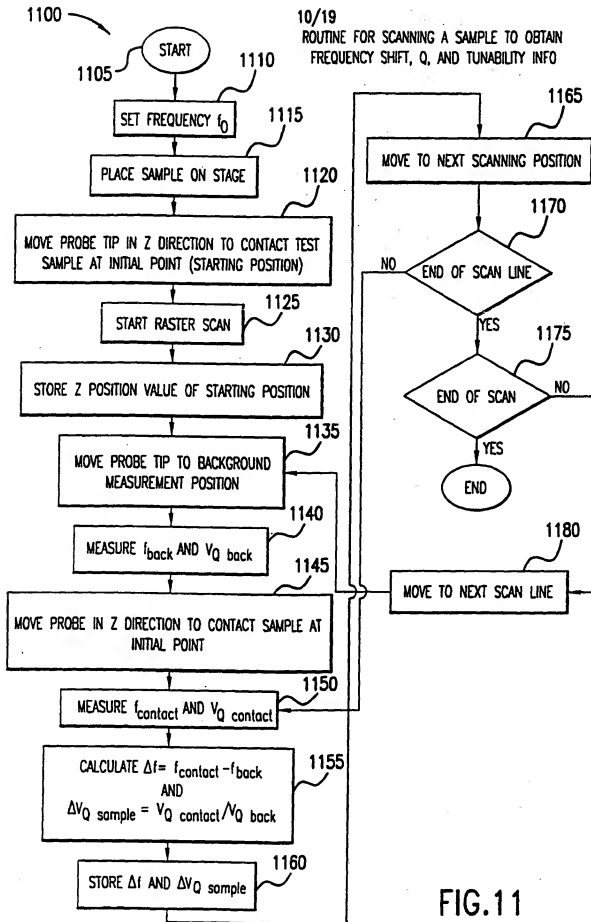
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PROBE CALIBRATION ROUTINE

FIG. 10



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ROUTINE FOR GENERATING A CALIBRATION CURVE

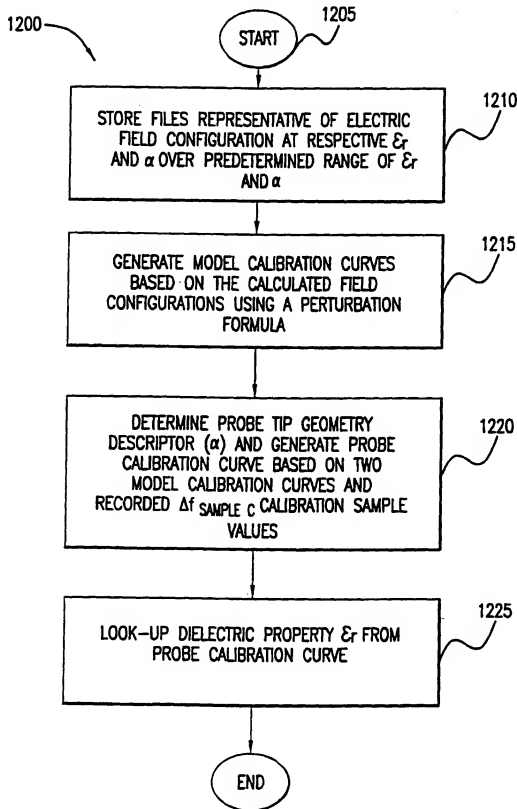


FIG. 12

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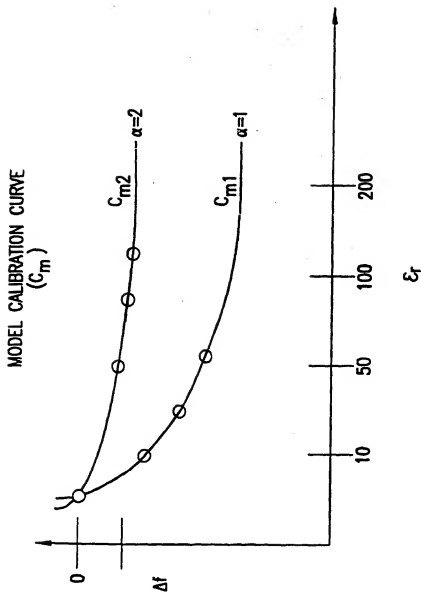


FIG.13

PROBE CALIBRATION CURVE
(C_p)

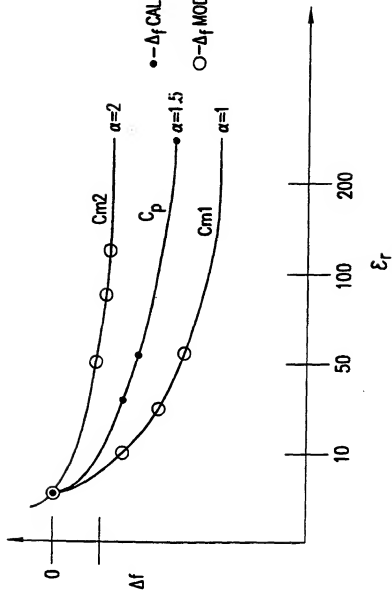


FIG.14

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FIG. 15

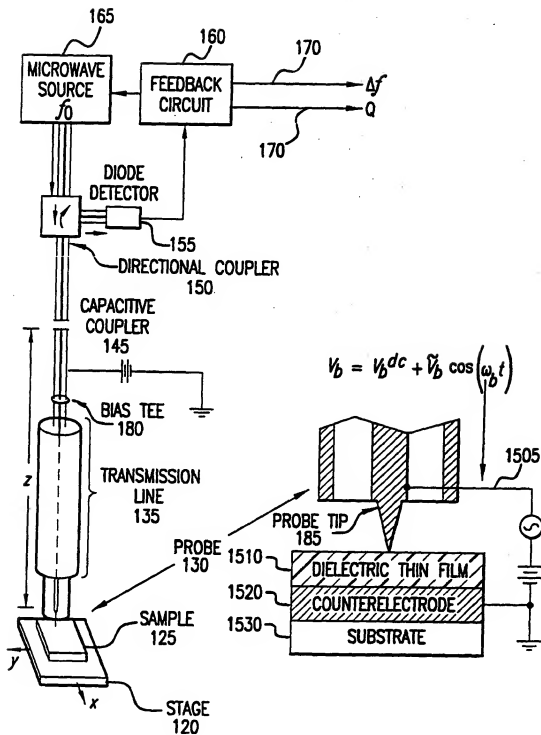
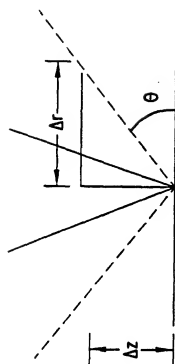


FIG.15



SMALL ASPECT RATIO = BLUNT TIP

$$\text{ASPECT RATIO} \equiv \alpha = \frac{\Delta z}{\Delta r} = \tan \theta$$

HIGH ASPECT RATIO = SHARP TIP

FIG.16

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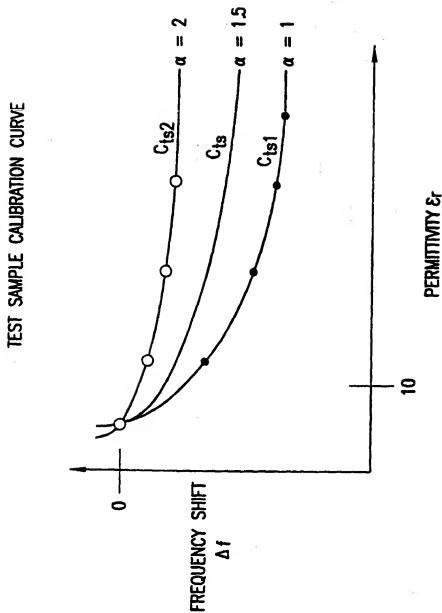


FIG.17

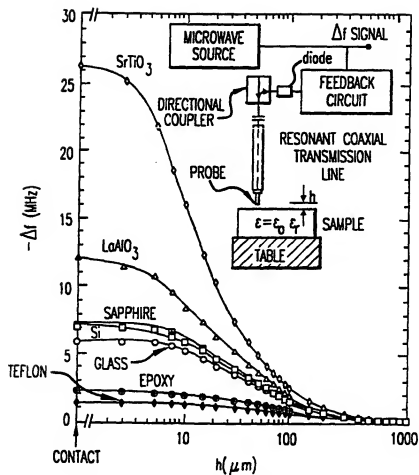


FIG.18

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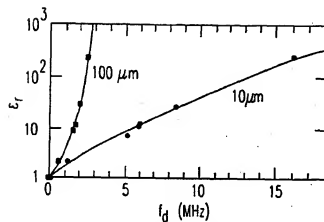


FIG.19

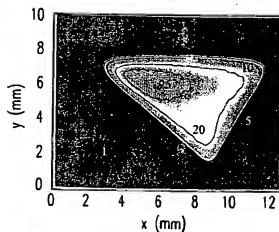


FIG.20

MATERIAL	EXPERIMENTAL VALUE	LITERATURE VALUE	FREQUENCY (GHz)	REFERENCES
SILICON	12	11.7	100	11
GLASS	12	6.7	10^{-3}	12
SrTiO_3	180	230	0.1	9
LaAlO_3	20	23.9	18	10
SAPPHIRE (CERAMIC)	20	10.0	100	11
TEFLON	2.1	2.1	10	9

FIG.21

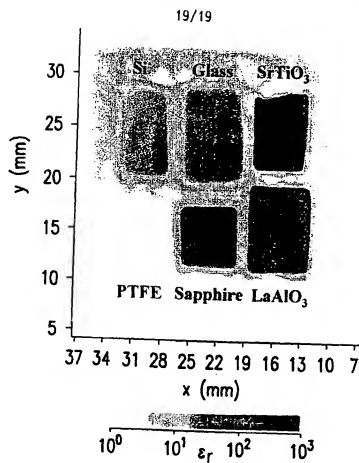


FIG. 22A

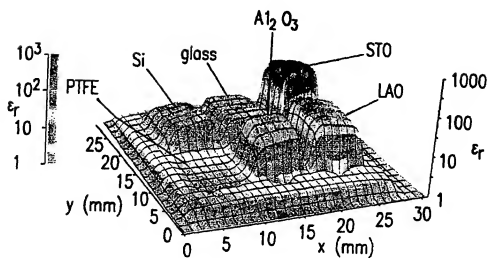


FIG. 22B